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IPW



Serial No. 10/673,873  
SEC.1084

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re Patent application of : **MAIL STOP AF**  
Sung-bae LEE : Group Art Unit 2823  
Serial No. 10/673,873 : Examiner M. Estrada  
Filed September 30, 2003 :

**METHOD OF FORMING A TRENCH FOR USE IN MANUFACTURING A  
SEMICONDUCTOR DEVICE**

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**REQUEST FOR RECONSIDERATION**

U.S. Patent and Trademark Office  
Customer Window, Mail Stop AF  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office action of July 27, 2006, Applicants submit the following:

For convenience, an up-to-date **Listing of Claims** begins on page 2 of this paper.

**Remarks/Arguments** which begin on page 7 of this paper.

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